

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	3	"6565962".pn.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/10/04 06:01
L2	4	porous adj film with polyimide and conductive adj metal	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/10/04 06:02
L3	3	porous adj film with insulating with conductive adj metal	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/10/04 06:04
L4	14	porous adj film with conductive adj metal	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/10/04 06:05
L5	902	porous adj film with metal\$4	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/10/04 06:05
L6	2	porous adj film with (coated impregnated) with metal\$4 adj layer	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/10/04 06:06
L7	1	"200243743"	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/10/04 06:14
L8	2	"5510395".pn.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/10/04 07:01
L9	0	porous adj imide and semiconductor	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/10/04 07:01
L10	48	porous adj polyimide and semiconductor	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/10/04 07:30
L11	74	porous adj polyimide and circuit	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/10/04 07:39
L12	7	"987294"	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/10/04 07:40

L13	2	"5231162".pn.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/10/04 07:42
L14	443487	porous adi polyimide with interlayer	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/10/04 07:42
L15	441617	porous adi polyimide with interlayer with circuit	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/10/04 07:43
L16	0	porous adj polyimide with interlayer with circuit	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/10/04 07:43
L17	4	porous adj polyimide with interlayer	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/10/04 07:43
L18	136	porous adj film with interlayer	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/10/04 07:43
L19	24	porous adj film with interlayer and polyimide	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/10/04 07:47
L20	5	porous adj film with interlayer with substrate and polyimide	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/10/04 07:48
L21	3	porous adj insulating adj film with interlayer with substrate	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/10/04 07:48
L22	6	porous adj insulating adj film with substrate with metal	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/10/04 07:48
L23	0	porous adj insulating adj film with wafer with metal	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/10/04 07:49
L24	0	porous adj insulating adj film same wafer with metal	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/10/04 07:49

L25	23	porous adj insulating adj film with metal	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/10/04 07:49
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